

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: ONO ET AL

FILED: August 27, 2001

FOR: RESIN ENCAPSULATED BGA-TYPE SEMICONDUCTOR DEVICE

DOCKET: NEC 01341

BOX PATENT APPLICATION
The Commissioner of Patents & Trademarks
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicants hereby attach U.S. Patent Office Form PTOL-1449, including copies of the prior art references listed therein together with the English language abstracts. These references are discussed in the specification. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitute prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,



Norman P. Soloway
Attorney for Applicant
Reg. No. 24,315

HAYES, SOLOWAY,
HENNESSEY, GROSSMAN
& HAGE, P.C.
175 CANAL STREET
MANCHESTER, NH
03101-2335 U.S.A.

603-668-1400

1c978 U.S. PRO
09/940249
08/27/01

#3 105
11-20-01
R. Stokes

(Use several sheets if necessary)

NEC 0134

Application Number

ONO ET AL

Filing Date

AUGUST 27, 2001

Group Art Unit

100-70 U.S. PRO
09/940249

[illegible][illegible]

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.